

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	SUJIT SHARAN ET AL.	Examiner:	Asok K Sarkar
Serial No.:	09/825,613	Group Art Unit:	2829
Filed:	April 03, 2001	Docket No.:	303.930US4
Title:	METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS		

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This responds to the Notice of Non-Compliant Amendment mailed on May 10, 2006. In compliance with 37 CFR 1.121, Applicant submits the following corrected section from Applicants' previously-submitted Amendment and Response filed February 22, 2006.